



PATENT
8074-1143

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Koichi NANIWAE Conf. 9283

Application No. 10/573,492 Group 2892

Filed May 15, 2006 Examiner E. Jones

METHOD OF CLEANING TREATMENT AND METHOD
FOR MANUFACTURING SEMICONDUCTOR DEVICE

AMENDMENT

Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

December 23, 2008

Sir:

In response to the Non-final Office Action mailed
August 27, 2008, please amend the above-identified application as
follows:

Amendments to the Claims are reflected in the listing
of claims which begins on page 2 of this paper.

Remarks begin on page 14 of this paper.